

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application No. 10/582,588

Filing Date June 09, 2006

First Named Inventor James S. Williams et al.

Art Unit Unknown 2827

Examiner Unknown C. Yoha

Attorney Docket No. DAVI258.003APC

(Multiple sheets used when necessary)

SHEET 1 OF 2

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| Examiner Initials | Cite No. | Document Number Number - Kind Code (if known) Example: 1,234,567 B1 | Publication Date MM-DD-YYYY | Name of Patentee or Applicant | Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear |
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Examiner Signature /Connie Yoha/

Date Considered 02/15/2010

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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